

APPLICATION DATA SHEET

Application Information

Application Type::	Regular
Subject Matter::	Utility
Title::	METHOD FOR THE PRODUCTION OF LOW DEFECT DENSITY SILICON
Attorney Docket Number::	985401/23401
Total Drawing Sheets::	3
Small Entity?::	No

Applicant Information

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Russia
Status::	Full Capacity
Given Name::	Vladimir
Middle Name::	V.
Family Name::	Voronkov
City of Residence::	Merano
Country of Residence::	Italy
Street of Mailing Address::	Via Nazionale, 59
City of Mailing Address::	Merano
State or Province of Mailing	
Address::	Italy
Postal Code of Mailing Address::	39012

Applicant Authority Type::	Inventor
Primary Citizenship Country::	US
Status::	Full Capacity
Given Name::	Robert
Middle Name::	J.

Family Name:: Falster
City of Residence:: London
Country of Residence:: England
Street of Mailing Address:: 501 Pearl Drive, P.O. Box 8
City of Mailing Address:: St. Peters
State or Province of Mailing
Address:: MO
Postal Code of Mailing Address:: 63376

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Iran
Status:: Full Capacity
Given Name:: Mohsen
Family Name:: Banan
City of Residence:: Grover
State or Province of Residence:: MO
Country of Residence:: US
Street of Mailing Address:: 501 Pearl Drive, P.O. Box 8
City of Mailing Address:: St. Peters
State or Province of Mailing
Address:: MO
Postal Code of Mailing Address:: 63376

Correspondence Information

Correspondence Customer Number:: 000321

Representative Information

Representative Customer Number:: 000321

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This application	Non- Provisional of	60/275,715	11/22/00
This application	Non- Provisional of	60/245,610	11/3/00

Assignee Information

Assignee Name:: MEMC Electronic Materials, Inc.